

Notice of Allowability	Application No.	Applicant(s)
	10/627,565	LIM ET AL.
	Examiner Sylvia R MacArthur	Art Unit 1763

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address--

All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. **THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS.** This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.

1. This communication is responsive to a telephone interview on Feb. 3,2005.
2. The allowed claim(s) is/are 1-7 and 9-20.
3. The drawings filed on 28 June 2002 are accepted by the Examiner.
4. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
 - a) All b) Some* c) None of the:
 1. Certified copies of the priority documents have been received.
 2. Certified copies of the priority documents have been received in Application No. _____.
 3. Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)).

* Certified copies not received: _____.

Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application.
THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.

5. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.
6. CORRECTED DRAWINGS (as "replacement sheets") must be submitted.
 - (a) including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached
 - 1) hereto or 2) to Paper No./Mail Date _____.
 - (b) including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date _____.
- Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d).
7. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.

Attachment(s)

1. Notice of References Cited (PTO-892)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)
3. Information Disclosure Statements (PTO-1449 or PTO/SB/08),
Paper No./Mail Date _____
4. Examiner's Comment Regarding Requirement for Deposit
of Biological Material
5. Notice of Informal Patent Application (PTO-152)
6. Interview Summary (PTO-413),
Paper No./Mail Date herewith.
7. Examiner's Amendment/Comment
8. Examiner's Statement of Reasons for Allowance
9. Other _____.

EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Jerome Marger on February 3,2005.

2. The application has been amended as follows:

Claim 1 now reads—

1. (Currently Amended) An apparatus for manufacturing an integrated circuit device, comprising:

a chamber for containing a fluid therein;

a guide, seated in the chamber, on which a plurality of wafers having an outer circumferential edge are located, the guide including at least one supporting member for supporting the wafers and a stopper member for preventing the wafers supported by the supporting member from contacting adjacent wafers; and

a transfer robot for loading and/or unloading the wafers to and/or from the guide, the transfer robot including:

a first arm for supporting a first position of the edge of the wafer; and

a second arm for supporting the edge of the wafer at a second position which is positioned higher than the first position of the first arm.

Claim 7 now reads—

7. (Currently Amended) The apparatus as set forth in claim 1,
~~the transfer robot including:~~
a first arm for supporting a first portion of the edge of the wafer; and
a second arm for supporting a second portion of the edge of the wafer, the second arm being shorter than the first arm.

Claim 8 has been cancelled.

In claim 9, “8” has been changed to - - 1 --.

In claim 10, “8” has been changed to - - 1 --.

In claim 14, “8” has been changed to - - 1 --.

Allowable Subject Matter

3. Claims 1-7 and 9-20 are allowed.

4. The following is an examiner’s statement of reasons for allowance:

The prior art of record fails to teach or fairly suggest an apparatus for manufacturing an integrated circuit device, comprising a transfer robot including a first and second arm wherein the arms are different lengths. Likewise, the prior art of record fails to teach or fairly suggest a stopper member as claimed in claims 17-20.

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5. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Sylvia R MacArthur whose telephone number is 571-272-1438. The examiner can normally be reached on M-F during the core hours of 8 a.m. and 2 p.m.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Gregory L. Mills can be reached on 571-272-1439. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).


Sylvia R MacArthur
Patent Examiner
Art Unit 1763

February 4, 2005


S. R. MacArthur
TECHNICAL EXAMINER